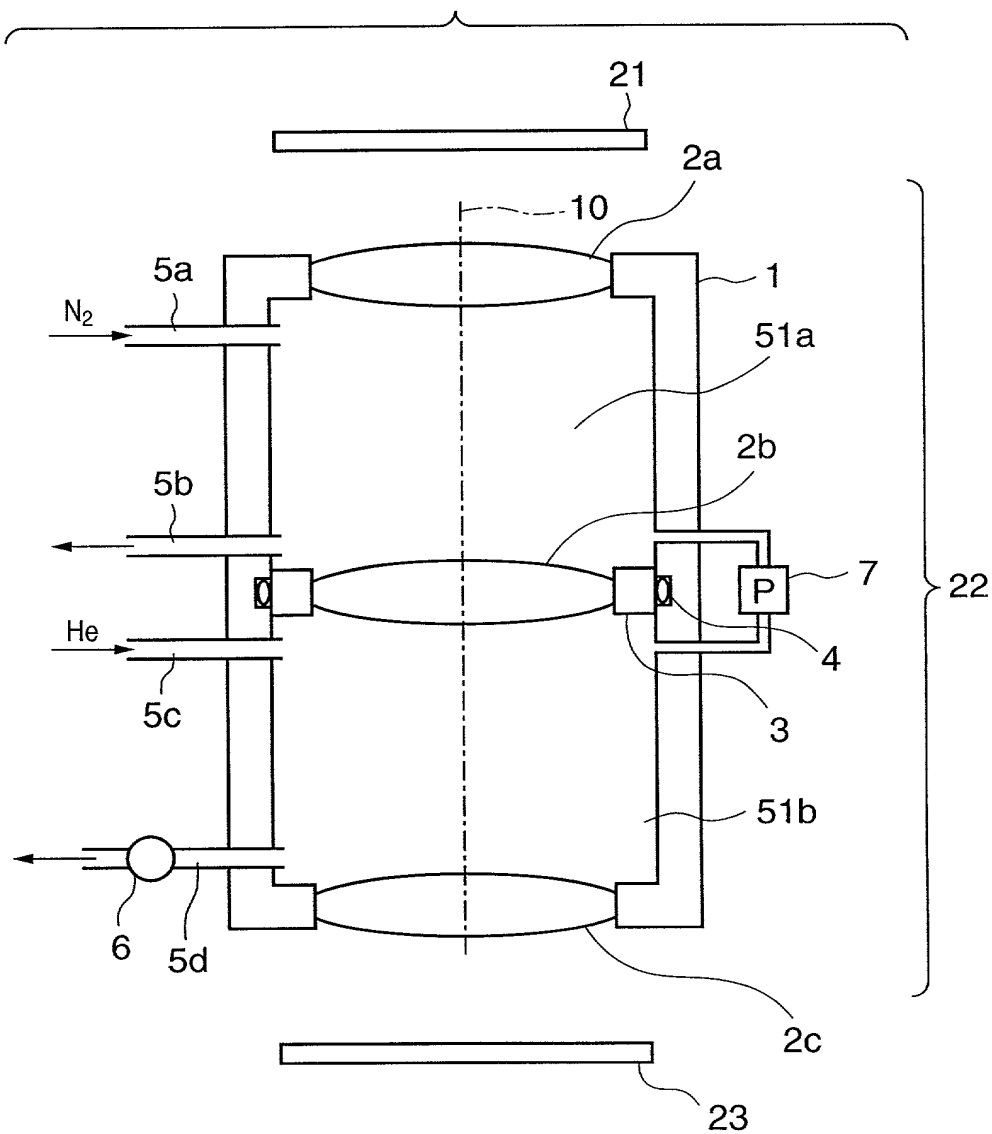


FIG. 1



SECRET

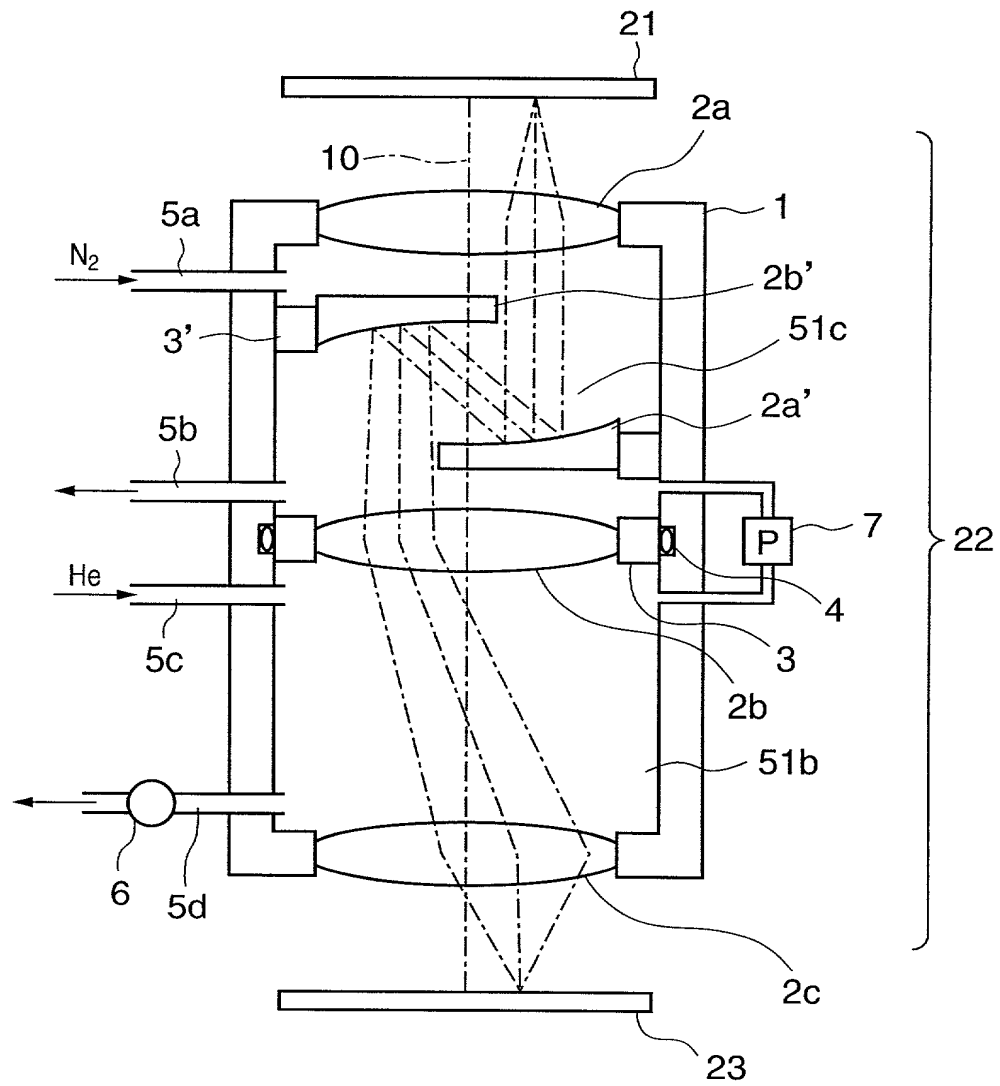


FIG. 3

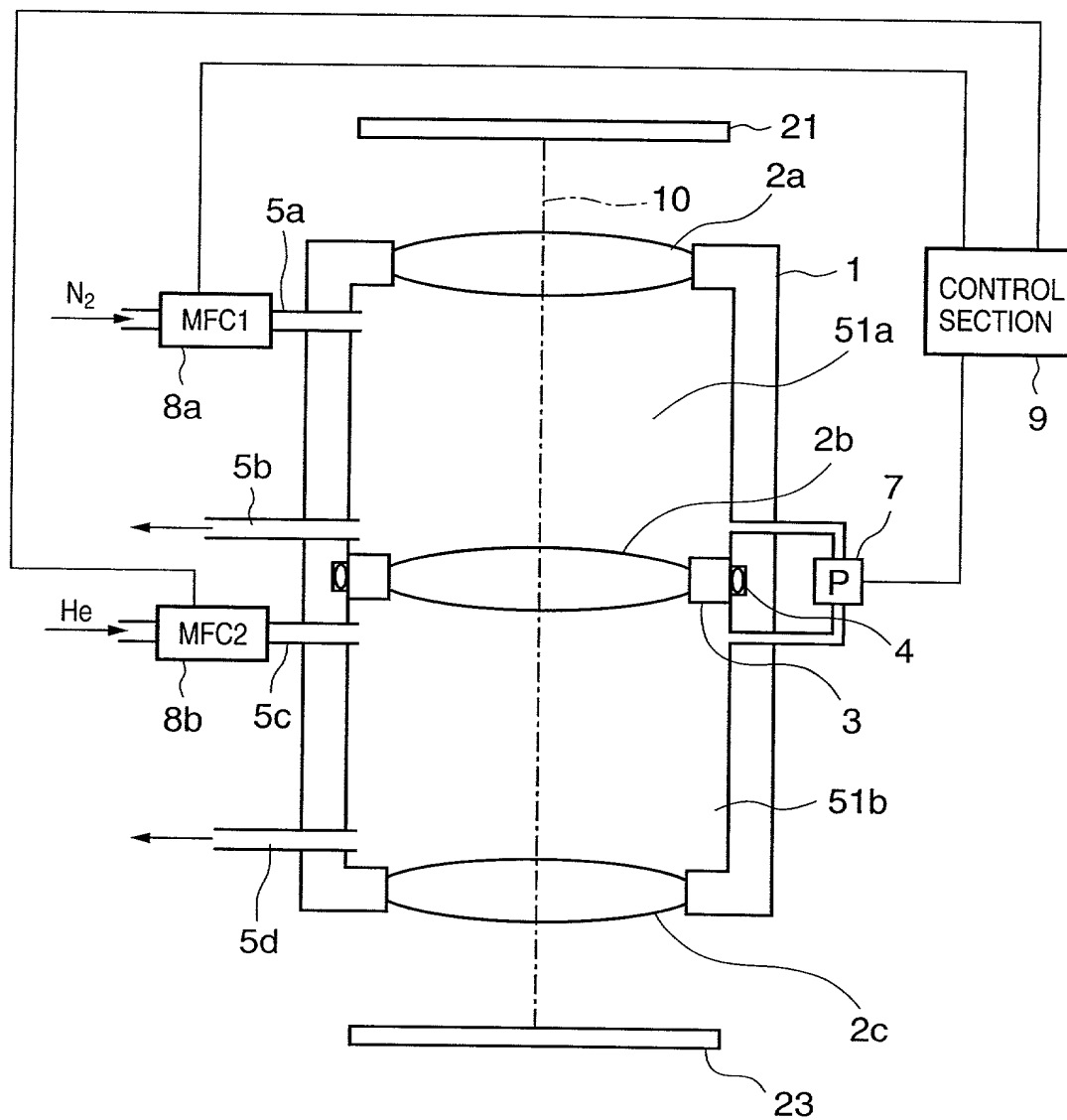


FIG. 4

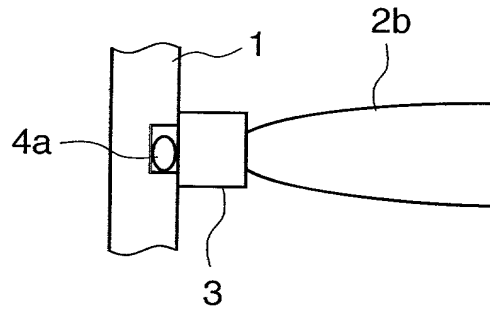


FIG. 5

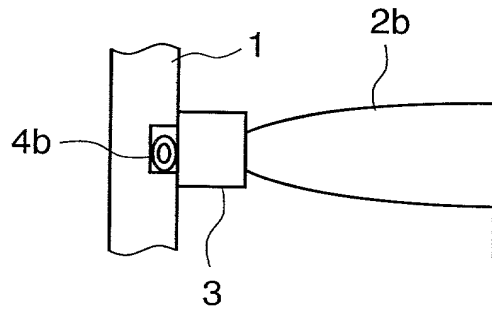


FIG. 6

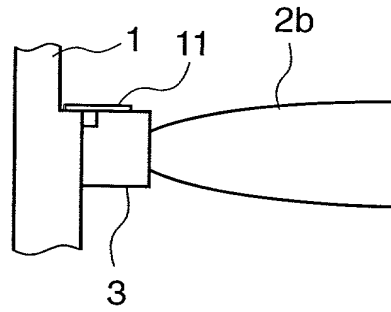


FIG. 7

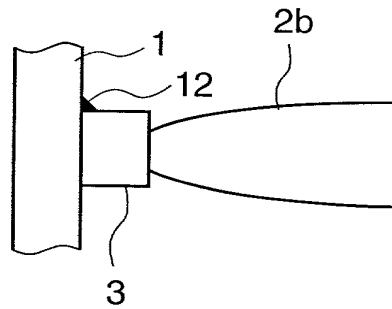


FIG. 8

AIR CONCENTRATION CHANGE IN He SPACE WITH
RESPECT TO PRESSURE DIFFERENCE BETWEEN SPACES

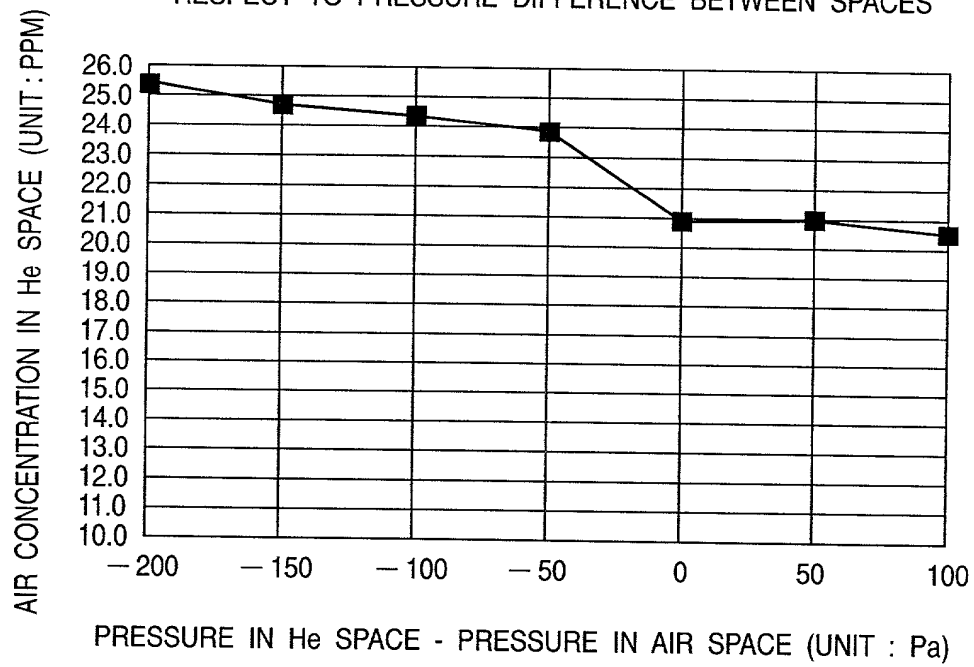


FIG. 9

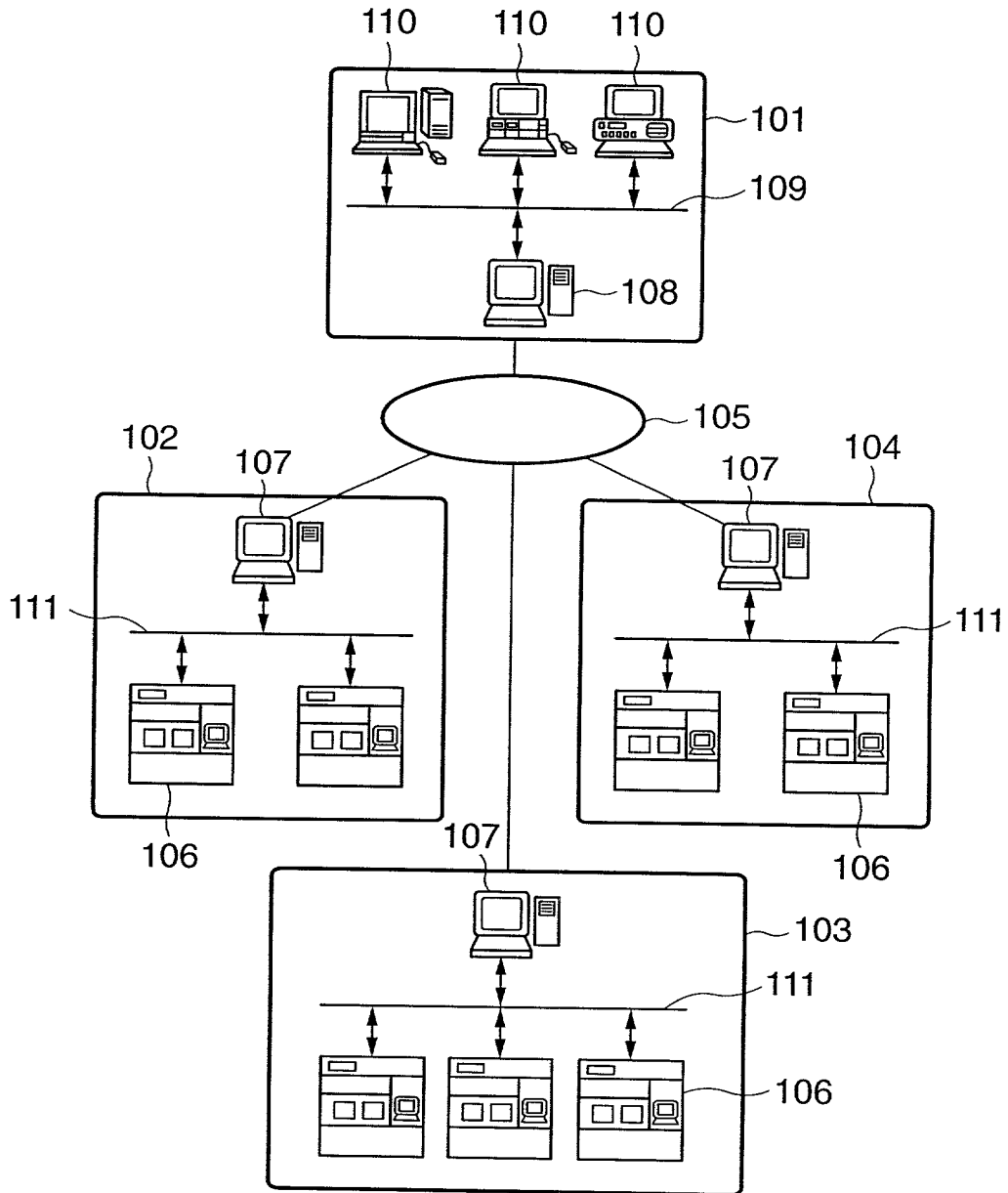


FIG. 10

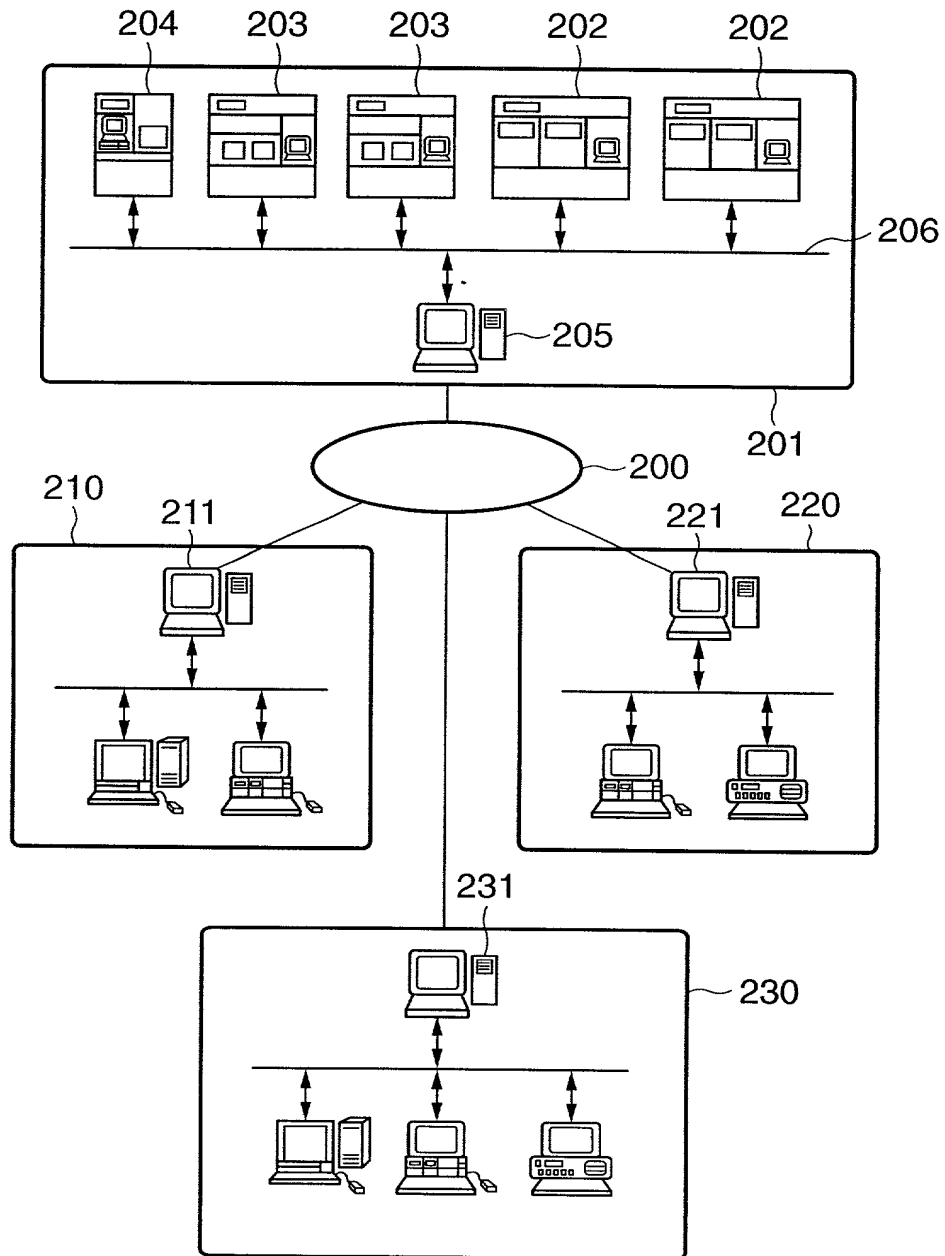


FIG. 11

URL

TROUBLE DB INPUT WINDOW

OCCURRENCE DATE ~ 404

TYPE OF APPARATUS ~ 401

SUBJECT ~ 403

SERIAL NUMBER S/N ~ 402

DEGREE OF URGENCY ~ 405

SYMPTOM ~ 406

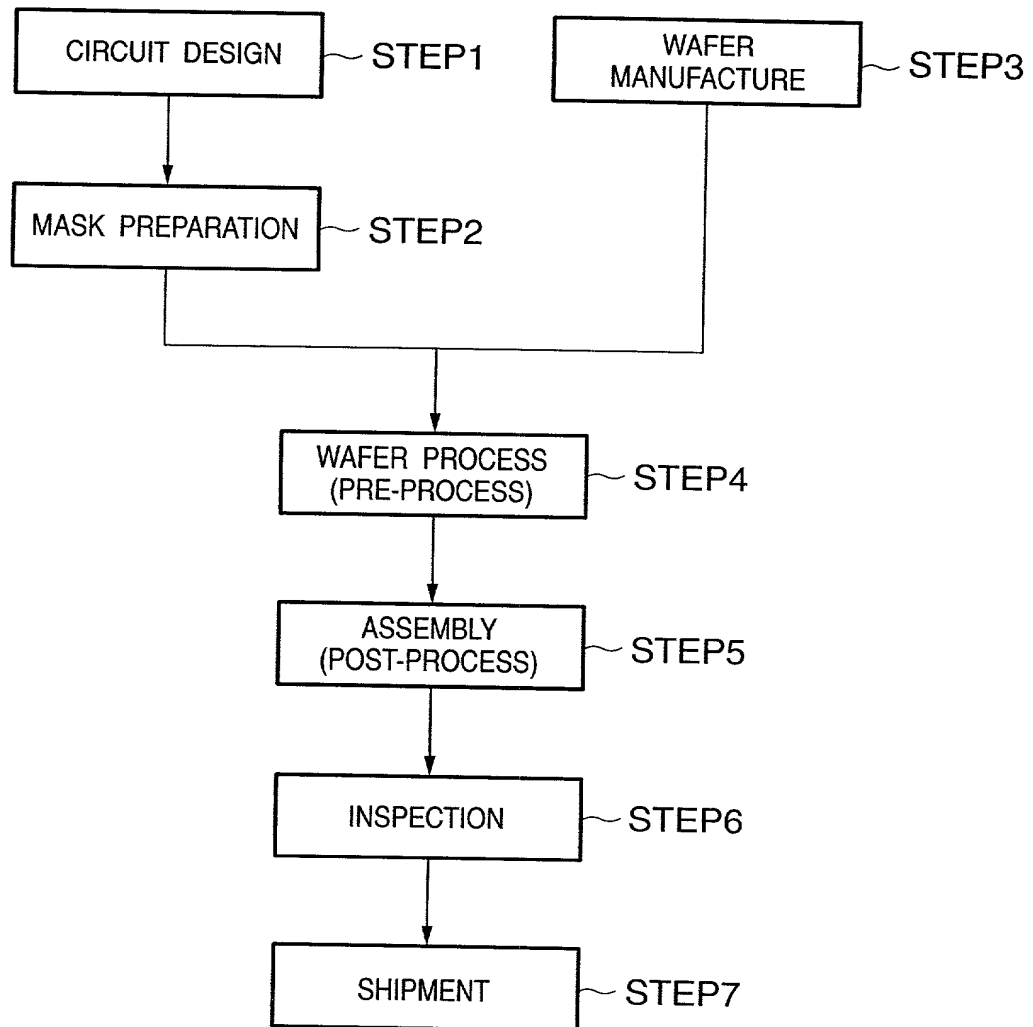
REMEDY ~ 407

PROGRESS ~ 408

410

411

412

FIG. 12

SEMICONDUCTOR DEVICE MANUFACTURING FLOW

FIG. 13